

S/N 10/ 720,409
confirmation no. 5057
Applicant Feng Chen
Response to Office Action dated 2006-09-25

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Attorney Docket: CS03-039

To: Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: William J. Stoffel 1735 Market St - Ste A455
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Subject:
S/N 10/ 720,409
Inventor Feng Chen
Confirmation no. 5057
Attorney Docket: CS03-039
File date: 11/24/2003
Title : **CMP Polishing Heads Retaining Ring Groove Design for Microscratch Reduction**
Group Art Unit: 3723
Examiner: Shakeri

**RESPONSE UNDER 37 CFR 1.116- EXPIDITED PROCEDURE
- EXAM GROUP 3723-**

RESPONSE TO OFFICE ACTION DATED 2006-09-25

Dear Sir:

Enclosed is a Response to Office Action dated 2006-09-25. Please consider the following remarks:

pls. DO NOT ENTER
JS
12/6/6

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION
Total 28 Pages in this Fax
I hereby certify that this correspondence is being :
[] FAXED to the central facsimile number of patent and trademark office at the following number (571) 273-8300 or
[] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.
Signature William J. Stoffel/ DATE November 27, 2006
William J. Stoffel Reg. No. 39,390 Customer number 30402